

Paper No.: ____

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Inventor(s): CHAPMAN, Glenn H.; SARUNIC, Marinko Venci; TU, Yugiang
Title: **DRY MULTILAYER INORGANIC ALLOY THERMAL RESIST FOR
LITHOGRAPHIC PROCESSING AND IMAGE CREATION**
Serial No.: Unassigned
Filed: Herewith
Date: 17 October 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Disclosure Statement Pursuant to 37 C.F.R. §1.56

Preliminary to the examination of this application, the applicant wishes to draw the Examiner's attention to the references listed on the attached copy of form PTO-1449. For the Examiner's convenience, copies of each of the listed references are submitted herewith.

REMARKS

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art". If the Examiner applies any of the documents as prior art against any claim in the application and applicant determines that the cited documents do not constitute "prior art" under United States law, applicant reserves the right to present the relevant facts and law regarding the appropriate status of such documents.

Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

Respectfully submitted,

By:


Gavin N. Manning

Registration No. 36,412

tel: 604.669.3432 ext. 224

fax: 604.681.4081

Vancouver, B.C.
CANADA

Paper No.: ____

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Inventor(s): CHAPMAN, Glenn H.; SARUNIC, Marinko Venci; TU, Yugiang
Title: **DRY MULTILAYER INORGANIC ALLOY THERMAL RESIST FOR
LITHOGRAPHIC PROCESSING AND IMAGE CREATION**
Serial No.: Unassigned
Filed: Herewith
Date: 17 October 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE STATEMENT
[Form PTO-1449 (Modified)]**

United States Patent Documents

Examiner	ID	Patent No.	Issue Date	Inventor(s)	Class	Sub-Cl	Filing Date
	US: 1	4,211,838	8 July 1980	Izu et al.			
	US: 2	4,082,861	4 April 1978	Izu et al.			
	US: 3	4,587,533	6 May 1986	Nakane et al.			
	US: 4	5,851,729	22 Dec. 1998	Takeuchi et al.			
	US: 5	5,998,066	7 Dec. 1999	Block et al.			
	US: 6	3,873,341	25 Mar. 1975	Alan R. Janus			
	US: 7	4,619,894	28 Oct. 1998	Carl O. Bozler			

Other Art

Examiner	ID	Author, Title, Date, Pertinent Pages, etc.
	OA: 1	Gelbart and Karasyuk, Proc. SPIE Emerging Lithographic Technologies III, V 3676, pg 786-793 (1999)
	OA: 2	

Examiner: _____

Date Considered: _____

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance **and** not considered. Include copy of this form with next communication to applicant.